

**AMENDMENT TRANSMITTAL LETTER**Docket No.  
1592-0178PUS1Application No.  
10/549,698-Conf. #9561Filing Date  
July 14, 2006Examiner  
K. T. ChenArt Unit  
1792

Applicant(s): Masanori SAKAI et al.

Invention: SUBSTRATE PROCESSING APPARATUS AND PRODUCING METHOD OF  
SEMICONDUCTOR DEVICE**MS Amendment**  
**Commissioner for Patents**  
P.O. Box 1450  
Alexandria, VA 22313-1450

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED						
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate		
Total Claims	12	- 20 =	0	x	52.00	0.00
Independent Claims	4	- 4 =	0	x	220.00	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>						
Other fee (please specify):						
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>						0.00

☒ Large Entity☐ Small Entity☒ No additional fee is required for this amendment.☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
A duplicate copy of this sheet is enclosed.☐ A check in the amount of \$ \_\_\_\_\_ is enclosed.☐ Payment by credit card. Form PTO-2038 is attached.☒ The Director is hereby authorized to charge and credit Deposit Account No. 02-2448  
as described below. A duplicate copy of this sheet is enclosed.☒ Credit any overpayment.☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.Dated: May 11, 2009Michael K. Mutter  
Attorney Reg. No.: 29,680BIRCH, STEWART, KOLASCH & BIRCH, LLP  
8110 Gatehouse Road  
Suite 100 East  
P.O. Box 747  
Falls Church, Virginia 22040-0747  
(703) 205-8000